



PATENT APPLICATION

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JPW

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Hiroyuki TOMIMATSU

Group Art Unit: 2814

Application No.: 10/782,810

Examiner: H. PHAM

Filed: February 23, 2004

Docket No.: 114371.01

For: SEMICONDUCTOR DEVICE AND METHOD
FOR MANUFACTURING THE SAME,
CIRCUIT SUBSTRATE AND ELECTRONIC
APPARATUS

MAIL STOP RCE

**LARGE ENTITY REQUEST FOR
CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. §1.114, Applicant(s) hereby request(s)
continued examination.

☒ Applicant further requests entry and consideration of the submission filed April 12, 2006.

The above-identified application was filed on or after June 8, 1995. Thus, entry is proper
under 37 C.F.R. §1.114(d).

Attached hereto is our check no. 179785 in the amount of ☒ \$790.00 as payment of the fees
set forth in 37 C.F.R. §1.17(e). The Commissioner is hereby authorized to charge any additional fees
or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two
duplicate copies of this page are enclosed.

Respectfully submitted,

James A. Oliff
Registration No. 27,075

Gang Luo
Registration No. 50,559

JAO:GXL/sqb

Date: May 12, 2006

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01 FC:1801	DEPOSIT ACCOUNT USE AUTHORIZATION Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461	790.00	0P
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